

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	TRUNG T. DOAN	Examiner: Sylvia MacArthur
Serial No.:	09/652,713	Group Art Unit: 1763
Filed:	August 31, 2000	Docket No.: 303.928US5
Title:	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING	

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**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This responds to the Notice of Non-Compliant Amendment mailed on February 15, 2006.  
In compliance with 37 CFR 1.173(b), Applicant submits the following corrected section from  
Applicants' previously-submitted Amendment and Response filed January 17, 2003.